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## FILED UNDER 35 U.S.C. 371

U.S. UTILITY Patent Application

PATENT NUMBER and ISSUE DATE

-		409			
APPL NUM	FILING DATE	CLÁSS	SUBCLASS	GAU	· EXAMINER
10019278	01/02/2002	250	42,000	2 <b>88</b>	看到这
APPLICANT	S: Delauna	ay Marc; S	Semeria Marie	Noelle;	Markhon
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** FOREIGN AP FRANCE 99/034	PLICATIONS VER 73 07/01/1999	RIFIED:			
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Foreign priority claims 35 USC 119 condition		-Beryes :		ATTO	ORNEY DOCKET NO
	is met edged Examiners's intid	⊒ yes 5 als	ı no	2172	18US2PCT
ITLE: Method a		ronic cyc	lotronic resona s	nce plasma	deposite of carbon nanofibre
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NOTICE OF ALLOWANCE MAILED			CLAIMS ALLOWED						
		Assistant Examiner	Total Claims		Print Claim for O.G				
ISSUE FEE			DRAWING						
Amount Due	Date Paid		Sheets Drwg.	Figs.Drv	Figs.Drwg. Print F				
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TERMINAL		Primary Examiner							
		PREPARED FOR ISSUE	Application Examiner						
	DISCLAMER	WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.							

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